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**APPLICATION
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INTERNAL CACHE FOR ON CHIP TEST DATA STORAGE

FIELD OF THE INVENTION

The present invention relates to the field of testing semiconductor devices; more
5 specifically, it relates to a testing method of a semiconductor device having an embedded
memory array.

BACKGROUND OF THE INVENTION

10 Semiconductor devices include various circuits according to the functions the
device has been designed to perform. The circuits generally comprise memory arrays for
storing data and logic circuits for performing the device design functions as well as
controlling the overall functioning of all circuits in the semiconductor device.

A tester is used for testing the functions of the semiconductor device. To test the
15 semiconductor device, a test program including test patterns designed to test the
semiconductor device functions, is loaded into the tester and the tester applies the
patterns to the semiconductor device. The results of the test are compared to expected
responses and a determination is made as to whether or not the semiconductor has passed
or failed the test.

Today's technology allows for some of the function of testing to be placed on the semiconductor device itself. For example, array built in self-test (ABIST) functions are used to test memory arrays and logic built in self-test (LBIST) functions are used to test logic functions.

- 5 A problem with testing today's large semiconductor devices, even using ABIST and LBIST, is providing the required test data to the device under test (DUT) and then collecting the results of the application of those tests. This is particularly difficult when the tests have to be applied at high speeds, and the test results have to be collected without interfering with the application of the test. An example is the expected
- 10 signatures in a LBIST environment and bitmap data in an ABIST environment.

- Collecting test data is further complicated by the fact that the amount of test data can be very large so that a large portion of tester time is spent in moving or waiting for data to be moved. Collecting test data is still further complicated when the resulting test data must be combined during a subsequent diagnostic phase and the final number of bits
- 15 to be used by the diagnostics is substantially less than the number of bits retrieved from the DUT. This occurs most notably when embedded arrays are tested in a start-stop-retrieve mode, in which a test is partially applied, stopped, diagnostic data retrieved and another portion of the test applied and so on.

- In more detail, collecting bit fail map data on embedded arrays from logic parts is
- 20 a very slow process for testers. One current method is to run ABIST on an embedded array with the tester recording all the cycles that ABIST was in when fails occurred.

Then, the test is repeated but with the tester stopping at the first cycle a fail occurred at.

Then the fail is read out. In most logic designs, the test cycle must be repeated, from the beginning, for the next fail. If a fail bitmap could be built up and stored on the die, the fail data could be read out to the tester after all the tests were run and the need to repeat the tests from the beginning for each fail would be eliminated and the time for testing
5 would be reduced.

Therefore, a need exists for a method of storing and retrieving test data as a function separate from the application of the test patterns, without interfering with the application of the test patterns or having to stop the tester to save the test results.

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SUMMARY OF THE INVENTION

A first aspect of the present invention is a method of testing a semiconductor device having a memory, comprising: selecting a portion of the memory; testing the selected portion of the memory; designating the selected portion of the memory as a
15 designated memory in response to an acceptable testing result; and storing data in the designated portion of the memory for retrieval at a later time.

A second aspect of the present invention is a method of testing a semiconductor device having a memory, comprising:
providing a designated memory; performing ABIST on a memory segment to generate
20 memory test data; storing the memory test data in the designated memory; and retrieving the test data at a later time.

A third aspect of the present invention is a method of testing a semiconductor device having a memory, comprising: providing a designated memory; performing LBIST on a device logic function to generate a set of LBIST signatures; storing the LBIST signatures in the designated memory; and retrieving the LBIST signatures at a
5 later time.

A fourth aspect of the present invention is a method of testing a function of a semiconductor device having a memory, comprising: providing a designated memory; performing a first test using a test pattern in a first corner of the test specification of the function of the semiconductor device; storing the result of the first test in the designated
10 memory; performing a second test using the test pattern in a second corner of the test specification of the function of the semiconductor device; retrieving the first test result from the designated memory; and comparing the first test result with the second test result.

A fifth aspect of the present invention is a semiconductor device comprising: a
15 memory; an ABIST engine adapted to test said memory; and an interface adapted to send test data to and receive test data from a designated portion of said memory.

BRIEF DESCRIPTION OF DRAWINGS

The features of the invention are set forth in the appended claims. The invention itself, however, will be best understood by reference to the following detailed description
5 of illustrative embodiments when read in conjunction with the accompanying drawings, wherein:

FIG. 1 is a general functional block diagram of a test system according to the present invention;

FIG. 2 is a detailed functional block diagram of semiconductor device according to a first
10 embodiment of the present invention;

FIG. 3 is a detailed functional block diagram of a semiconductor device according to a second embodiment of the present invention;

FIG. 4 is a detailed functional block diagram of a semiconductor device according to a third embodiment of the present invention;

15 FIG. 5 is a flowchart illustrating the major method steps according to the present invention;

FIG. 6 is a flowchart illustrating the method steps of the first embodiment of the present invention;

FIG. 7 is a flowchart illustrating the method steps of the second embodiment of the
20 present invention; and

FIG. 8 is a flowchart illustrating the method steps of the third embodiment of the present invention.

DETAILED DESCRIPTION OF THE INVENTION

A first embodiment of the present invention is directed to memory testing, a second embodiment to logic testing and a third embodiment to comparison of test results.

5 FIG. 1 is a general functional block diagram of a test system according to the present invention. All three embodiments are illustrated in FIG. 1. In FIG. 1, a semiconductor device **100** includes a memory **105**, device logic functions **110**, an ABIST function **115**, an LBIST function **120** and a compare function **125**. Memory **105** comprises a plurality of memory segments **130A** through **130E**. ABIST function **115** includes an ABIST engine **135** and an ABIST interface **140**. Optionally, ABIST engine **135** may include a data decompress function and ABIST interface **140** may include a data compress function. LBIST function **120** includes an LBIST engine **145** and an LBIST interface **150**. Optionally, LBIST engine **145** may include a data decompress function and LBIST interface **150** may include a data compress function. Compare function **125** may be used to compare memory bit-fail maps generated by ABIST ENGINE **135** or test result data generated by LBIST engine **145** obtained at different corners. A corner is a specification of the environment in which the test is run. The corner may specify supply voltage, temperature and clock cycle time. Compare function **125** is simply a set of logic that takes two sets of similar data, compares them bit by bit, and then outputs a single bit designating a compare or mis-compare. Optionally, compare function **125** may include a data decompress function. ABIST engine **135** is coupled to memory **105** and additional memory **195** by an ABIST bus **160**. LBIST engine **120** is coupled to device logic

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functions **110** through logic circuits **165** via test data bus **167A** and data lines **167B**.

ABIST interface **140** is coupled to memory **105** by an ABIST interface bus **170**. LBIST interface **150** is coupled to memory **105** by an LBIST interface bus **175**. Compare

function **125** is coupled to memory **105** by a compare bus **180**. Tester **155** is coupled to

5 ABIST engine **135**, LBIST engine **145** and compare function **125** by tester bus **185**.

Finally, semiconductor device **100** includes a repair function **190** coupled between tester **155** and memory **105** (or integral with the memory) for performing soft repair of the memory **105**. Although FIG. 1 shows the repair function to be controlled by the tester, the repair function could be controlled by ABIST engine **135** or a special repair tool.

10 Memory **105** may be integral to semiconductor device **100** or external to the semiconductor device, but located in the kerf of the wafer on which the semiconductor device is fabricated, in which case wires connecting memory **105** with semiconductor device **100** would be severed when the wafer is diced. The kerf of the wafer is the non-functional area between semiconductor chips. Similarly, if memory **105** resides in the
15 kerf of the wafer, repair function **190** may also reside in the kerf portions of the wafer.

ABIST engine **135** performs ABIST memory tests on memory **105** (and additional memory **195** as well) and serves to pre-test a particular memory section, one of memory segments **130A** through **130E**. After a particular memory segment has been pre-tested and found good (or soft repaired) the pre-tested memory segment is designated for
20 storage of test data. ABIST interface **140** communicates with the designated memory segment (in the present example memory segment **130B**) for storing and retrieving additional ABIST test data, according to a first embodiment of the present invention.

ABIST interface **140** is shown coupled to designated memory segment **130B** by ABIST interface bus **170**, however the ABIST interface may share ABIST bus **160** or be coupled to the functional memory buses for the purpose of storing and retrieving additional ABIST test data. ABIST function **115**, ABIST bus **160** and ABIST interface bus **170**

5 need not be present on semiconductor device if the first embodiment of the present invention is not to be practiced.

LBIST engine **145** performs LBIST logic tests on device logic functions **110** and communicates with designated memory segment **130B** for storing and retrieving additional LBIST test data via LBIST interface **150** and LBIST interface bus **175**,

10 according to a second embodiment of the present invention. A pre-tested good memory segment is required as part of the second embodiment of the present invention and this may be provided using ABIST engine **135** as described above, or direct memory testing if no ABIST engine **135** has been provided on semiconductor device **100**. If the present invention is practiced without the second embodiment, LBIST function **120** and LBIST

15 interface bus **175** need not be present on semiconductor device **100**.

FIG. 2 is a detailed functional block diagram of a semiconductor device according to a first embodiment of the present invention. In FIG. 2, a read/write (R/W) multiplexer (MUX) **200** is coupled to memory **105** (containing designated memory segment **130B**) by a R/W select line **205** for placing memory **105** into a read or a write state in response to a

20 R/W signal applied to the R/W select line by ABIST function **115**. An enable MUX **210** is coupled to memory **105** by an enable line **215** for enabling read or write to memory **105** in response to an enable signal applied to the enable line by ABIST function **115**.

An address MUX **220** is coupled to memory **105** by an address bus **225** for selecting particular memory segments and particular memory cells in the memory to write data into or read data out of in response to an address word applied to the address bus by ABIST function **115**. A data in MUX **230** is coupled to memory **105** by a data bus **235** for writing data applied to the data bus into the memory by ABIST function **115**. R/W select MUX **200**, enable MUX **210**, address MUX **220** and data in MUX **230** are controlled by ABIST function **115** through control lines **240** in ABIST engine bus **160**. In the example of FIG. 2, ABIST interface bus **170** and ABIST engine bus **160** illustrated separately in FIG. 1, are one and the same in FIG. 2.

Memory **105** is coupled to latches in a scan chain **250** by a data out bus **245A**. A CLK signal **255** controls scan-in and scan out of data from memory **105** through scan chain **250** to a data out bus **245B**. In addition the latches in scan chain **250** are connected to a first select MUX **260** via data out bus **245B**. Additional memory **195** is coupled to a second input of a first select MUX **260** by a data out bus **245C**. First select MUX **260** determines whether test data from memory **105** or additional memory **195** is to be written into designated memory segment **130B**. The output of first select MUX **260** is coupled to an input of second select MUX **265** and to a first input of a compare function **267** by a selected data bus **270A**. The output of second select MUX **265** is coupled to an input of data in MUX **230** by a selected data bus **270B**. Second select MUX **265** determines whether bit-map or bit-fail map data is written into designated memory segment **130B**. An ABIST data bus **272** is coupled to a second input of compare function **267** to create bit-fail maps from bit maps by comparing the bit-map to an expected bit map from

ABIST function **115**. The output of compare function **267** is coupled to a second input of second select MUX **265** by a selected data bus **270C**.

Repair function **190** is coupled between the tester and memory **105** (or integral with the memory) for performing soft repair of the memory.

5 In operation ABIST function **115** tests memory **105**, the resultant data flows through scan chain **250**, and optionally compare function **267**, and is written into designated memory segment **130B**. In the case of additional memory **195**, ABIST function **115** tests memory **195**, and the resultant bit map or bit-fail map is written into memory segment **130B** to be scanned out at a later time.

10 Data collected in designated memory segment **130B** is outputted to the tester, for example, by scanning in address data to address MUX **220** (or by having ABIST function **115** generate the address data), pulsing a CLK signal **255** and scanning the data out of first scan chain **250** to the tester.

FIG. 3 is a detailed functional block diagram of a semiconductor device according to a second embodiment of the present invention. In FIG. 3, a read/write (R/W) multiplexer (MUX) **200** is coupled to memory **105** (containing designated memory segment **130B**) by a R/W select line **205** for placing memory **105** into a read or a write state in response to a R/W signal applied to the R/W select line by LBIST interface **150**. An enable MUX **210** is coupled to memory **105** by an enable line **215** for enabling read or write to memory **105** in response to an enable signal applied to the enable line by LBIST interface **150**. An address MUX **220** is coupled to memory **105** by an address bus **225** for selecting particular memory segments and particular memory cells in the memory

to write data into or read data out of in response to an address word applied to the address bus by LBIST interface **150**. A data MUX **230** is coupled to memory **105** by a data bus **235** for writing data applied to the data bus into the memory by LBIST interface **150**. R/W select MUX **200**, enable MUX **210**, address MUX **220** and data in MUX **230** are
5 controlled through control lines **275** in LBIST interface bus **175**.

Memory **105** is coupled to a first scan chain **280A** by a data out bus **245A**. LBIST engine **145** is coupled to logic circuits **165** by test data bus **167A**, and logic circuits **165** are coupled to first and last scan chains **280A** and **280B** by test data lines **167B**. Device logic functions **110** are coupled between first scan chain **280A** and a last
10 scan chain **280B**. While two scan chains (**280A** and **280B**) are illustrated there may be up to twenty or more scan chains interspersed through device logic functions **110**, each scan chain coupled between logic circuits **165** and a Multiple Input Shift Register (MISR) **285**. A CLK signal **255** applied to all scan chains from first scan chain **280A** through last scan chain **280B**, controls scan-in and scan out of test patterns from LBIST
15 engine **145** to MISR **285** via data lines **167C**. Scan chain **280A** also has an additional data out **245D** for sending data from memory **105** out of semiconductor device **100**. MISR **285** is coupled to an input of data in MUX **230** by test data bus **245B**.

Repair function **190** is coupled between the tester and memory **105** (or integral with the memory) for performing soft repair of the memory.

20 In operation LBIST function **120** tests logic device functions **110**, and the resultant pattern is scanned out through scan chains **280A** and **280B** into MISR **285**.

From MISR **285** the pattern is written into designated memory segment **130B** through data out bus **245B**, MUX **230** and data in bus **235**.

Data collected in designated memory segment **130B** is outputted to the tester by scanning in address data to address MUX **220** (or by having LBIST function **120**

- 5 generate the address data), pulsing CLK signal **255** and scanning the data out of first scan chain **280A** to the tester.

FIG. 4 is a detailed functional block diagram of a semiconductor device according to a third embodiment of the present invention. In FIG. 4, a read/write (R/W)

multiplexer (MUX) **200** is coupled to memory **105** (containing designated memory

- 10 segment **130B**) by a R/W select line **205** for placing memory **105** into a read or a write state in response to a R/W signal applied to the R/W select line by LBIST interface **150**.

An enable MUX **210** is coupled to memory **105** by an enable line **215** for enabling read or write to memory **105** in response to an enable signal applied to the enable line by

LBIST interface **150**. An address MUX **220** is coupled to memory **105** by an address bus

- 15 **225** for selecting particular memory segments and particular memory cells in the memory to write data into or read data out of in response to an address word applied to the address bus by LBIST interface **150**. A data MUX **230** is coupled to memory **105** by a data bus **235** for writing data applied to the data bus into the memory by LBIST interface **150**.

R/W select MUX **200**, enable MUX **210**, address MUX **220** and data in MUX **230** are

- 20 controlled through control line **275** in LBIST interface bus **175**.

Memory **105** is coupled to a first scan chain **280A** and to a first input of compare function **125** by a data out bus **245A**. LBIST engine **145** is coupled to logic circuits **165** by test data bus **167A**, and logic circuits **165** are coupled to first and last scan chains **280A** and **280B** by test data lines **167B**. Device logic functions **110** are coupled between

5 first scan chain **280A** and a last scan chain **280B**. While two scan chains (**280A** and **280B**) are illustrated, there may be up to twenty or more scan chains interspersed through device logic functions **110**, each scan chain coupled between logic circuits **165** and a register **290**. A CLK signal **255** applied to all scan chains from first scan chain **280A** through last scan chain **280B**, controls scan-in and scan out of test patterns from LBIST

10 engine **145** to register **290** via data lines **167C**. Scan chain **280A** also has an additional data out **245D** for sending data from memory **105** out of semiconductor device **100**. Register **290** is coupled through data out bus **245B** to an input of data in MUX **230** and to a second input of compare function **125**. Compare function **125** has an output **295**.

Repair function **190** is coupled between the tester and memory **105** (or integral

15 with the memory) for performing soft repair of the memory.

In operation LBIST function **120** performs a first test of logic device functions **110**, the resultant first pattern is scanned out through scan chains **280A** and **280B** into register **290**. From register **290** the first pattern is written into designated memory segment **130B** through data in MUX **230**. Next, LBIST function **120** performs a second

20 test of logic device functions **110**, the resultant second pattern is scanned out through scan chains **280A** and **280B** into register **290**. From register **290** the second pattern is compared in compare function **125** with data from the first pattern in memory segment

130B, and a compare signal **295** is outputted. As mentioned above, the first and second test patterns may be corner test patterns, in which case the results of testing two corners will be compared. The results of the compare of two corners can be converted into a simple pass/fail signal.

- 5 The number of addresses in memory segment **130B** should match the length of scan chains **280A** and **280B**. If the number of addresses does not match, then alternative methods of storing the data must be used, such as folding multiple bits into the same address.

- FIG. 5 is a flowchart illustrating the major method steps according to the present invention. In step **300**, a suitable memory array is selected, in the present example this is memory **105**. A suitable memory array is a memory array with enough words and bits per word in one or more memory segments to meet the storage requirements of the test data to be stored in that memory. This memory array may be a memory array designed for support of semiconductor device **100** functions and fabricated integral to the
- 10 semiconductor device. Alternatively, the memory array may be one designed specifically for storage of test data. In the case of a memory specifically designed for storage of test data, the memory array may be fabricated integral to semiconductor device **100** or in the kerfs between semiconductor devices during wafer processing and wired to the
- 15 semiconductor device. Dicing the wafer would sever the wiring. In step **305**, a memory segment(s) of the memory array is selected.
- 20 segment(s) of the memory array is selected.

Next, in step **310**, the selected memory segment(s) is tested using ABIST engine **135**. Alternatively, the selected memory segment(s) may be tested using a conventional

memory tester having a test program and storage for the resultant test data. If, in step 315, the memory segment is good the method continues to step 320. If the memory segment is not good, then, in step 325, a soft repair is attempted. A soft repair is one that can be initiated from tester 155, and persists until at least completion of testing of semiconductor device 100. If, in step 330, the memory segment(s) is good, then the method continues to step 320. If the memory segment is not good then, in step 335, a determination is made if another untested memory segment(s) exists. If another untested memory segment exists the method loops back to step 305 otherwise the process terminates and the invention cannot be practiced using the selected memory array.

In step 320, the good memory segment is designated for storage of test data. In the present example, the designated memory segment(s) is memory segment 130B. In step 340, a test is performed on semiconductor device 100. In optional step 345, the test data is compressed. The compression can occur in the semiconductor device 100, in circuitry outside semiconductor device 100, or within the test program executed on tester 155. In step 350, the data resulting from the test is stored in the designated memory segment. In step 355, the contents of the designated memory segment are read out of the designated memory. In optional step 360, the test data is sent to tester 155. Finally, in step 365 the data is decompressed, if necessary.

FIG. 6 is a flowchart illustrating the method steps of a first embodiment of the present invention. In step 375, a memory array or memory segment on semiconductor device 100 is selected to bit-fail map. The selected array segment may be any of memory segments 130A through 130E from memory array 105 or a memory segment from one of

memory **195**. In step **380** ABIST is performed on the selected memory to create a bit map. Two options exist, the bit map can be stored directly or the bit map can be converted to a bit-fail map before storage by comparing actual with expected data. In optional step **385**, the bit map itself may be compressed and then in step **390**, stored in designated memory segment **130B**. In step **395**, fail data is generated by comparing actual data to the expected data. Then in optional step **400** the fail data is compressed and then in step **405**, stored in designated memory segment **130B**. If optional compress data step **400** is not performed, steps **375**, **380**, **395** and **405** may be repeated with the results of each loop being ORed with the data already in designated memory segment **130B**. The OR function may reside in ABIST interface **140**.

In step **410**, the contents of the designated memory segment are read out of the designated memory. Data collected in designated memory segment **130B** is outputted to the tester by repeatedly scanning in address data to address MUX **220**, pulsing CLK signal **255** and scanning the data out of first scan chain **250** (to the tester) until all addresses have been read. In step **415**, the test data is sent to tester **155**. Finally, in step **420** the data is decompressed, if necessary.

FIG. 7 is a flowchart illustrating the method steps of a second embodiment of the present invention. In the present example, LBIST patterns are grouped into multiples of N test patterns, and the test description includes the cumulative fail signature for each group of N test patterns. In step **450**, every LBIST pattern is applied to device logic functions **110**. The LBIST signature in MISR **285** is not reset. In optional step **455**, the cumulative fail signature for every N patterns (read from MISR **285**) is compressed and

in step 460, the cumulative fail signature for every N patterns is stored in designated memory segment 130B. It should be observed that the width of MISR 285 cannot exceed the word length of designated memory segment 130B.

In step 465, the contents of the designated memory segment are read out of the designated memory. Data collected in designated memory segment 130B is outputted to the tester by scanning in address data to address MUX 230, pulsing CLK signal 255 and scanning the data out of first scan chain 280A (to the tester.) In step 470, the test data is sent to tester 155. Finally, in step 475 the data is decompressed, if necessary.

In step 485, tester 155 determines which groups of N patterns, if any, failed. If in step 490, there were no fails, the method ends. If there were fails then in step 495, the first group of N patterns in which a fail occurred is selected and in step 500, every LBIST pattern in the selected group is applied to device logic functions 110. The LBIST pattern in MISR 285 is reset. In optional step 505, the fail signature for every pattern in the selected group (read from MISR 285) is compressed and in step 510, the LBIST signature for every pattern in the selected group is stored in designated memory segment 130B.

In step 515, tester 155 determines which pattern(s) in the selected group failed. Then in step 520, it is determined if there are additional failing groups of N patterns. If there are additional failing groups of N patterns, then the method loops to step 495, otherwise the process is complete. Thus each failing pattern is uniquely identified.

FIG. 8 is a flowchart illustrating the method steps of a third embodiment of the present invention. A condition for the third embodiment is that memory segment 130B

contains at least as many bits as there are scannable latches interfacing with device logic functions **110** if the test results are not to be compressed. As an option for improved performance, when the test results are not compressed, select or specifically supply a designated memory segment having a word length equal to the number of scan chains in

5 device logic functions **110**. In step **540**, a specific test pattern is run at a first corner of the test specification to create a first set of test data. In optional step **545**, the first set of test data is compressed. In step **550**, the first set of test data is stored in designated memory segment **130B**. Next in step **555** the same specific test pattern run in step **540** is run again, except at a different corner of the test specification to create a second set of

10 test data.

Next, in step **560**, the address of designated memory segment **130B** is scanned into memory **105**. Next in step **565**, CLK signal **255** is pulsed and in step **570**, the first set of test data is scanned out of memory segment **130B**. In **570**, the first set of test data is decompressed if it was compressed in step **545** and scanned out to test compare **125**.

15 In step **575**, the second set of test data is scanned out to test compare **125**. Next, in step **580**, if the first and second test data match then in step **585**, a pass signal is sent to tester **155**. If in step **580**, the first and second test data do not match then in step **590**, a fail signal is sent to tester **155**. In step **595**, it is determined if the specified test pattern is to be run at another, different corner. If not, the method is complete. If another corner is

20 to be run, in step **600**, the corner is selected and the method loops to step **555**.

The description of the embodiments of the present invention is given above for the understanding of the present invention. It will be understood that the invention is not

to the particular embodiments described herein, but is capable of various modifications, rearrangements and substitutions as will now become apparent to those skilled in the art without departing from the scope of the invention. Therefore it is intended that the following claims cover all such modifications and changes as fall within the true spirit
5 and scope of the invention.

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